PATENT APPLICATION

0321.70917

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplicant:

Jamie R. Link et al.

Serial No.:

10/567,917

Patent No.

7,318,903

Conf. No.: 5897

Filed:

February 6, 2006

Issued:

January 15, 2008

For:

PHOTONIC SENSOR PARTICLES

AND FABRICATION METHODS

Art Unit:

1763

Examiner:

Culbert, Roberts P.

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Attn: Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

April 1, 2008

Date

Registration No. 43,874

Attorney for Applicant(s)

REQUEST FOR CERTIFICATE OF CORRECTION **UNDER RULE 1.322**

Attn: Certificate of Corrections Branch Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.322, patentees, through their attorneys, respectfully request that a Certificate of Correction be issued in the above-referenced patent.

The errors occurred as a result of mistakes on the part of the Patent and Trademark Office and the changes include the following:

In the Claims:

Claim 1:

Col. 7, line 26, please delete "silicon" (Preliminary Amendment, claim 1, line 3).

Col. 7, line 27, please delete "silicon" (Preliminary Amendment, claim 1, line 4).

Col. 7, line 29, please delete "dielectric mirror" and insert --patterned layer--therefor (Preliminary Amendment, claim 1, line 5).

Col. 7, line 32, please delete "to a second patterned layer" (Preliminary Amendment, claim 1, line 8).

Claim 2:

Col. 7, line 42, please delete "silicon" (Preliminary Amendment, claim 2, line 1).

Claim 4:

Col. 7, line 46, please delete "dielectric" and insert --patterned-- therefor ((Preliminary Amendment, claim 4, line 1).

Col. 7, line 47, please delete "mirror" and insert --layer-- therefor (Preliminary Amendment, claim 4, line 2).

Claim 7:

Col. 7, line 54, please delete "silicon" (Preliminary Amendment, claim 7, line 2).

Claim 8:

Col. 7, line 57, please delete "silicon" (Preliminary Amendment, claim 8, line 2).

Claim 12:

Col. 8, line 4, please delete "silicon" (Preliminary Amendment, claim 12, line 2).

Claim 13:

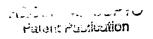
Col. 8, line 6, please delete "(10) of porous silicon" and insert -- of porous material-- therefor (Preliminary Amendment, claim 13, line 1).

Col. 8, line 9, please delete "(12)" (Preliminary Amendment, claim 13,

line 3).

Col. 8, line 11, please delete "(14)" (Preliminary Amendment, claim 13,

line 4).



Claim 16:

Col. 8, line 21, please delete "(10)" (Preliminary Amendment, claim 16, line 1)

Col. 8, line 22, please delete "silicon" and insert --material-- therefor (Preliminary Amendment, claim 16, line 2).

Col. 8, line 27, please delete "silicon particles (10)" and insert --particles-therefor (Preliminary Amendment, claim 16, line 5).

Col. 8, line 28, please delete "(12)" (Preliminary Amendment, claim 16, line 5).

Col. 8, line 29, please delete "(14)" (Preliminary Amendment, claim 16, line 6).

Claim 21:

Col. 8, line 43, please delete "(12,14)" (Preliminary Amendment, claim 21,

line 3).

Col. 8, line 44, please delete "silicon" (Preliminary Amendment, claim 21,

line 3).

Col. 8, line 50, please delete "silicon" (Preliminary Amendment, claim 21,

line 8).

REMARKS

A Certificate of Correction incorporating the delineated change is enclosed in duplicate herewith. Since the mistake was on the part of the Patent and Trademark Office, a Certificate of Correction should be issued without expense to the patentee and such is respectfully requested.

Respectfully submitted,

GREER, BURNS & CRAIN, LTD.

By

Arik B. Ranson

Registration No. 43,874

Customer No. 24978

April 1, 2008 300 South Wacker Drive **Suite 2500** Chicago, Illinois 60606

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(312) 360-9315

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UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO

7,318,903

DATED

January 15, 2008

INVENTOR(S)

Jamie R. Link and Michael J. Sailor

It is certified that an error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In the Claims:

Claim 1	Col. 7, line 26 Col. 7, line 27 Col. 7, line 29 Col. 7, line 32	Please delete "silicon" Please delete "silicon" Please delete "dielectric mirror" and insertpatterned layer therefor Please delete "to a second patterned layer"
Claim 2	Col. 7, line 42	Please delete "silicon"
Claim 4	Col. 7, line 46 Col. 7, line 47	Please delete "dielectric" and insertpatterned therefor Please delete "mirror" and insertlayer therefor
Claim 7	Col. 7, line 54	Please delete "silicon"
Claim 8	Col. 7, line 57	Please delete "silicon"
Claim 12	Col. 8, line 4	Please delete "silicon"
Claim 13	Col. 8, line 6 Col. 8, line 9 Col. 8, line 11	Please delete "(10) of porous silicon" and insertof porous material therefor Please delete "(12)" Please delete "(14)"
Claim 16	Col. 8, line 21 Col. 8, line 22 Col. 8, line 27 Col. 8, line 28 Col. 8, line 29	Please delete "(10)" Please delete "silicon" and insertmaterial therefor Please delete "silicon particles (10)" and insertparticles therefor Please delete "(12)" Please delete "(14)"
Claim 21	Col. 8, line 43 Col. 8, line 44 Col. 8, line 50	Please delete "(12,14)" Please delete "silicon" Please delete "silicon"

MAILING ADDRESS OF SENDER:

PATENT NO 7,318,903 RECEIVED-USPT Patent Publicullun

Steven P. Fallon GREER, BURNS & CRAIN, LTD. 300 South Wacker Drive, 25th Floor Chicago, IL 60606

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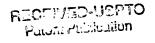
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